



RYUKA.007AUS

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shin-Ichi Hashimoto et al.) Art Unit 2881
)
Appl. No. : 10/672,469)
)
Filed : September 26, 2003)
)
For : ELECTRON BEAM EXPOSURE)
APPARATUS, DEFLECTION)
APPARATUS, AND ELECTRON)
BEAM EXPOSURE METHOD)
)
Examiner : Anthony G. Quash)
_____)

AMENDMENT

Hon. Commissioner
of Patents and Trademarks
Alexandria, VA 22313-1450

Dear Sir:

This amendment is submitted in response to the office action mailed October 5, 2004 from the United States Patent and Trademark Office for the above-identified patent application. Please make the following changes: